



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Thomas A. Figura et al.

Serial No.: 09/470,650

Filed: December 22, 1999

Title: USE OF A PLASMA SOURCE TO FORM A LAYER
DURING THE FORMATION OF A SEMICONDUCTOR DEVICE

§
§ Group Art Unit: 2829
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§ Examiner: Lisa Kilday
§
§ Atty. Docket: 94-0280.04
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AMENDMENT AND RESPONSE TO THE
OFFICE ACTION DATED OCTOBER 8, 2003

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:	
Date <u>11/5/03</u>	<u>Susan Jerome</u> Signature

Dear Sir:

Applicants herein respond to the Office Action dated October 8, 2003. Please amend the above-captioned application as follows.